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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

KUN-HONG CHEN

Serial No.: 10/627,751

Filed: July 28, 2003

For: METHOD OF FORMING LIGHTLY
DOPED DRAINS

Art Unit: 2823

Examiner: NGUYEN, KHIEM D.

INFORMATION DISCLOSURE STATEMENT FILED UNDER 37 C.F.R. § 1.97(c)(1)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Fee Only

Sir:

Applicants wish to make of record in the above-identified application the document or documents referenced on the attached Form PTO-1449. A copy of each reference is enclosed herewith. Further, the undersigned hereby certifies that:

- ☒ each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. The cited references are mentioned in an Examination Report dated February 18, 2005 (cover page enclosed) received from the Chinese Patent Office in applicant's corresponding Chinese patent application and are believed relevant for at least that reason. English language Abstracts are enclosed for the Japanese and Taiwanese references; or
- ☐ no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign

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